

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: Bruno GHYSELEN et al.

Confirmation No.:

8095

Application No.:

10/615,259

Group Art Unit:

2818

Filing Date:

July 9, 2003

Examiner:

Thao P. Le

For:

PROCESS FOR TRANSFERRING A

Attorney Docket No.:

4717-7500

LAYER OF STRAINED

SEMICONDUCTOR MATERIAL

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Sir:

Pursuant to Applicant's duty of disclosure under 37 C.F.R. § 1.56, enclosed is a Form PTO-1449 listing twelve (12) references for the Examiner's review. References C1 and C3 were published prior to the filing of the present application.

Copies of references B1-B5 and C1-C3 are enclosed herewith. Also enclosed is a copy of the International Search Report from the corresponding PCT application. Copies of U.S. patent references A1-A4 will be provided if the Examiner so requests.

It is respectfully requested that the references be made of record in this application by the Examiner's completion and return of the attached Form PTO-1449.

No fee is believed to be due for the submission of the these references. Should any fees be required, however, please charge such fees to Winston & Strawn LLP Deposit Account No. 50-1814.

Respectfully submitted,

May 28, 2004

E. Bradley Could

(Reg. No. 41,792)

For: Allan A. Fanucci

(Reg. No. 30,256)

WINSTON & STRAWN LLP

Customer No. 28765

202-371-5771

LICT OF DEFENDANCES CITED BY ADDITIONAL						ATTY. DOCKET NO.:	APPLICATION NO.:				
LIST OF REFERENCES CITED BY APPLICANT Form PTO-1449 (Use several sheets if necessary)						4717-7500	10/615,259				
						APPLICANT:					
						Bruno GHYSELEN et al.  FILING DATE: GROUP:					
MAY 2 8	2004	Sheet I of I			July 9, 2003			2812			
P.		IIC DATENTI			DOCI				-		
U.S. PATENT DOCUMENTS											
*EXAMINER INITIAL	CITE NO.	DOCUMENT NUMBER	DATE	NAME		CLASS	SUBCLASS	FILING APPROF	DATE IF PRIATE		
	Al	6,524,935	02/2003	Canaper	i et al		438	478			
	A2	2003/0089901	05/2003	Fitzgera	ld		257	19			
	A3	6,603,156	09/2003	Rim			257	190			
	A4	6,737,670	05/2004	Cheng, Zhi-Yuan		an	257	19			
FOREIGN PATENT DOCUMENTS											
		DOCUMENT NUMBER DATE			COUNTRY		· CLASS	SUBCLASS	TRANSLATION		
		DOCUMENT NUMBER	DATE			COUNTRI	CLASS	SUBCLASS	YES	NO	
	B1	2001168342	6/2001	JP							
	В2	WO 02/15244	02/2002	wo							
	В3	WO 02/27783	04/2002	wo							
	B4	WO 02/071493	09/2002	wo							
	В5	WO 02/080241	10/2002	WO					٠.		
								<u> </u>			
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, Etc.)											
Hobart, K.D. et al., On Scaling the Thin Film Si Thickness of SOI Substrates, A Perspective on Wafer  Bonding for Thin Film Devices, Naval Research Laboratory, Electronics Science and Technology division Washington, DC 20375											
	C2	Mizuno, T. et al., High Performance Strained-Si p-MOSFETs on SiGe-on-Insulator Substrates Fabricated by SIMO Technology, Electron Devices Meeting, 1999. IEDM Technical Digest International, Washington, DC, USA 5-8 December 1999, Piscataway, NJ									
	C3 Tong, Q.Y. et al., Semiconductor on Wafer Bonding, Science and Technology, Interscience Technology, Johnson Wiley & Sons, Inc.										
EXAMINER					DATI	ATE CONSIDERED					

\*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.